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## **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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Sheet 1 of 2

**Complete If Known**

|                        |                  |
|------------------------|------------------|
| Application Number     | 10/634500        |
| Filing Date            | August 05, 2003  |
| First Named Inventor   | MARIE B. O'REGAN |
| Group Art Unit         | 1771 2879        |
| Examiner Name          | DALE D. DOWD     |
| Attorney Docket Number | CL2332USNA       |

Sheet 1 of 2

**U.S. PATENT DOCUMENTS**

## FOREIGN PATENT DOCUMENTS

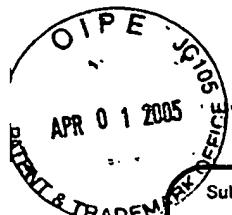
**Examiner  
Signature**

**Date Considered**

5/16/06

**\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.**

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



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| Examiner Name        | DALI DONG                |

Attorney Docket Number CL2332USNA

## OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

| Examiner Initials * | Cite No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T <sup>2</sup>           |
|---------------------|-----------------------|---|--------------------------|
| D.D.                |                       | Thurn-Albrecht, et al., "Ultrahigh-Density Nanowire Arrays Grown in Self-Assembled Diblock Copolymer Templates", Science, (2000), pages 2126-2129, Volume 290   | <input type="checkbox"/> |
| D.D.                |                       | Desai, et al., "Bis-alkylation of Meldrum's acid", Applied Physics Letters, (1999), India   | <input type="checkbox"/> |
| D.D.                |                       | Chou, et al., "Lithographically induced self-construction of polymer microstructures for resistless patterning", Applied Physics Letters, (1999), Volume 75, Number 7, New Jersey   | <input type="checkbox"/> |
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Examiner  
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5/16/06

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